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Journal of Alloys and Compounds 251 (1997) 373–374

Journal of ALLOYS AND COMPOUNDS

Author Index of Volume 251

Abrutis, A., 264, 288
Aindow, M., 123, 172
Al-Rjob, R., 111
Amrein, T., 138
Apostol, I., 48
Aprili, M., 156
Arrouy, F., 11, 118
Auzary, S., 37
Ayache, J., 78, 185

Badawi, F., 37
Baixeras, J., 142
Baumann, M., 138
Becht, M., 310
Belot, J.A., 243
Ben Ayadi, Z., 232
Bergs, R.M.H., 206
Berkowski, M., 1
Berkowski, M., 7
Berling, D., 179
Beuran, C.F., 103
Beuran, F.C., 240
Biegel, W., 176
Bigelyte, V., 288
Bijlsma, M.E., 15, 31
Bimbault, L., 37
Blank, D.H.A., 15, 31, 196, 206
Boikov, Yu.A., 193
Bollmeier, Th., 176
Bonevich, J., 78
Bosak, A.A., 337
Boudissa, M., 150
Bouzehouane, K., 213
Bozovic, I., 201
Bruynseraede, Y., 87
Buchholz, D.B., 278

Camerlingo, C., 34, 83
Campion, R.P., 161
Cardona, M., 7, 23, 70, 99
Caristan, E., 107, 142
Carris, M.W., 270
Castel, X., 74
Chabert-Rocabois, F., 297
Chang, R.P.H., 278
Char, K., 355
Chenevier, B., 322
Chen, J., 328
Claeson, T., 19
Collin, L., 103
Condorelli, G.G., 297, 314, 332
Contour, J.P., 185, 209
Cook, S.L., 360

Dubu, R., 48
Dahmen, K.-H., 270, 284, 318
Dahmen, U., 78
Dam, B., 27, 114
Daridon, A., 11, 118
Degardin, A., 107
de Groot, D.G., 27, 114
De Riccardis, F., 34
Del Vecchio, A., 34, 83, 179
Delabouglise, G., 351
Depond, J.M., 232
Deville Cavellin, C., 103, 240
di Uccio, U.S., 56, 332
Dias, C., 328
Didier, N., 322
Diete, W., 176
DiMeo Jr., F., 347
Dolin, C., 185
Dreßen, J., 44
Drouet, M., 185, 209
Dubourdieu, C., 322, 351
Dubreuil, D., 213
Dumoulin, L., 156
Duran, C.R., 347

Earwaker, L.G., 123, 172
Ebihara, K., 228
Eckstein, J.N., 201
Endo, T., 87
Eustache, B., 103, 240

Felten, F., 264, 288
Figueras, A., 284
Fischer, Ø., 11
Fisher, B., 209
Forkl, A., 146
Fragalà, I.L., 314, 332
Frassica, A., 314
Freyhardt, H.C., 366
Frikach, K., 150
Fröhlich, K., 264, 284
Fuflyigin, V.N., 337

Gaboriaud, R.J., 37
Galindo, V., 322
Garcia-Lopez, J., 94, 166
Garry, G., 213
Gaugue, A., 232

Germain, P., 103, 222, 240
Gerritsma, G.J., 196
Géry, O., 213
Gómez, A.M., 218
González, E.M., 218
González, J.M., 218
Gorbenko, O.Yu., 303, 337, 342
Graboy, I.E., 318
Grajcar, M., 129
Granozio, F.M., 56
Grishin, A.M., 228
Guilloux-Viry, M., 74, 156
Güntherodt, G., 44
Gustafsson, M., 19
Gyulmezov, M., 7

Hårsta, A., 134
Haage, T., 23, 70
Habermeier, H.-U., 23, 70, 99, 146, 161
Hadjiev, V.G., 7
Hasen, J., 87
Hatterer, C.J., 103, 240
Hesse, D., 44
Hinds, B., 278
Hinds, B.J., 328, 347
Hitchman, M.L., 297
Hoffmann, A., 87
Hoffschulz, H., 44
Hogan, T.P., 328
Horbelt, K., 161
Horton, T.J., 156
Huang, Y., 278
Hüttner, D., 65

Ikegami, T., 228
Iliev, M.N., 7, 99
Ivanov, I., 7
Ivanov, Z.G., 193

Jaccard, Y., 11
Jooß, C., 146

Kaiser, Th., 176
Kannewurf, C.R., 328, 347
Kaufmann, M., 138
Kaul, A.R., 303, 318, 337, 342
Kazimirov, A., 70
Khubeis, I., 111
Kinder, H., 366
King, P.J., 161
Kirchhoff, V., 366
Klippe, L., 249, 264
Koster, P., 114
Kötzler, J., 138
Krause, U., 337
Kreisler, A., 107, 142, 232
Krellmann, M., 307
Kronmüller, H., 146
Kúš, P., 129

Laguës, M., 103, 222, 240
Lalu, F., 156
Lanza, G., 314, 332
Latyshev, Yu.I., 236
Le Duigou, J., 78
Le Paven-Thivet, C., 74
Lebedev, O., 351
Lebedev, O.I., 206
Lederman, D., 87
Lee, S.Y., 41
Leggieri, G., 179
Leibold, B., 161
Lei, J.S., 278
Lemaître, Y., 166
Lesueur, J., 156
Linker, G., 65
Locquet, J.-P., 11, 118
Loegel, B., 179
Lu, J., 134
Luches, A., 179
Luisa De Giorgi, M., 179

Machajdík, D., 284
Mächler, E., 11, 118
MacManus-Driscoll, J.L., 355
Mage, J.C., 166
Mahajan, S., 278
Mairet, V., 240
Malandrino, G., 314, 332
Maleev, V.V., 318
Mansart, D., 166
Marcilhac, B., 166
Markov, N.V., 318
Marks, T.J., 243, 278, 328, 347
Markworth, P.R., 278
Martin, J.-C., 142
Martinoli, P., 11
McNeely, R.J., 243, 328, 347
McPhail, D.S., 355
Mehdaoui, A., 179
Mercandalli, L.M., 94

Elsevier Science S.A.

Merkle, K.L., 278
Meyer, O., 65
Michalowicz, A., 103
Moeckly, B., 355
Moerman, R., 31, 196
Molodyk, A.A., 303, 337
Monceau, P., 236
Montgomery, N.J., 355
Morishita, T., 310
Morley, S.M., 161
Moscovici, J., 103
Müller, G., 176
Musolf, J., 292

Nakielski, G., 138
Neumayer, D.A., 243
Neumüller, H.-W., 366
Nevelskaya, J.E., 236
Norris, D.J., 123, 172
Novozhilov, M.A., 337

Obi, B., 254
Ohkubo, M., 65
Olsson, E., 19
Otway, D.J., 254

Padiou, J., 74
Partiot, C., 103, 240
Patlagan, L., 209
Pavlenko, V.N., 236
Pech, T., 107
Peerdeman, F., 114
Perret, J., 11
Perrin, A., 74, 156
Pignard, S., 264, 288
Pisch, A., 264
Plecenik, A., 129
Polyakov, S.N., 318
Popov, V., 7

Rabier, J., 37
Ravelosona, D., 185, 209
Rebane, Ya.A., 342
Rector, J., 27
Rector, J.H., 114
Reedy, C.J., 243
Rees, Jr, W.S., 254
Reiner, J., 65
Richards, B.C., 360
Rickertsen, A., 138
Rijnders, A.J.H.M., 206
Rogalla, H., 15, 31, 196, 206
Roshko, A., 31
Rosova, A., 284, 322
Ruf, T., 70
Ruggiero, B., 34
Russo, M., 34, 83

Saltyte, Z., 288
Samoylenkov, S.V., 342
Sarnelli, E., 34
Sarrhini, O., 142
Schey, B., 176
Schilling, M., 138
Schindler, J.L., 328, 347
Schmatz, U., 264, 307, 351
Schmidt, W., 366
Schuller, I.K., 87
Schulte, B., 360
Seidel, P., 129
Selbmann, D., 264, 307
Sénateur, J.P., 264, 288, 351
Senoussi, S., 150
Sergent, M., 74
Shamlian, S.H., 297
Shingai, K., 228
Siegenthaler, H., 11, 118
Siejka, J., 94, 166
Slaski, M., 123
Šouc, J., 284
Stahl, H., 44
Stäuble-Pümpin, B., 27
Stern, C.L., 243
Stoian, R., 48
Stork, F.J.B., 31
Stratan, A., 48
Stritzker, B., 176, 366
Studebaker, D.B., 243
Studebaker, D.L., 328
Svetchnikov, V.L., 318, 342

Taoufik, A., 150
Tapfer, L., 34, 83, 179
Teiserskis, A., 288
Thomas, O., 322
Thorel, A., 78
Toukan, K., 111
Traverse, A., 103
Trætholt, C., 27

Valentino, M., 332
van Silfhout, A., 15
Van Tendeloo, G., 206
Vávra, I., 284
Vélez, M., 218
Vengalis, B., 288
Verbist, K., 206
Verhoeven, M.A.J., 196, 206
Vicent, J.L., 218

Wahl, G., 249, 337
Warthmann, R., 146
Weiss, F., 264, 284, 288, 307, 351
Wellhöfer, F., 123, 172
Wessels, B.W., 347
Williams, E.J., 11, 118
Winkler, D., 19
Wirth, G., 138
Woodall, P., 123, 172
Wördenweber, R., 366
Wormeester, H., 15

Xu, X.Z., 103, 240

Yamagata, Y., 228
Yi, H.R., 19

Zakharov, N.D., 44
Zandbergen, H.W., 318, 342
Zegenhagen, J., 23
Zhang, P., 70
Zhang, P.X., 99

ELSEVIER

Journal of Alloys and Compounds 251 (1997) 375–380

Journal of ALLOYS AND COMPOUNDS

Subject Index of Volume 251

Acoustic waves
optical and photoacoustic studies of target ablation for LPVD of YBCO thin films 48
AC susceptibility measurements
AC susceptibility measurements of films with different structural qualities 179
Anisotropy
field-anisotropy of critical current of YBaCuO films sputtered on various types of substrates 142
anisotropy of the critical current in YBCO thin films grown by metal organic chemical vapour deposition 351
Apical oxygen
study of apical oxygen atoms in a spin-ladder cuprate compound by X-ray absorption spectroscopy near the Cu K edge 103
Atomic-layer fabrication
atomic-layer fabrication of high-T_c tunnel junctions 201

Bi-2212
characteristic doping-dependent properties of HTS cuprate thin films prepared via MOCVD 347
$Bi_2Sr_2CaCu_2O_{8+x}$ films
TEM investigation of halide CVD grown $Bi_2Sr_2CaCu_2O_{8+x}$ films 134
$Bi_2Sr_2CaCu_2O_8$ single crystal whiskers
micron scale stacked structures fabricated from BSCCO 2212 single crystal whiskers 236
Bolometer
interface thermal modelling and characterisation of YBaCuO infrared bolometers 232
Buffer layer
characterization of the interface between laser ablated YBCO film and buffered sapphire substrate 41
Buffer layers
YSZ buffer layers on technical substrates for HTSC current applications prepared by AAMOCVD 307
preparation of buffer layers for HTS materials by MOCVD 310
growth of epitaxial TlBaCaCuO *a*-axis oriented films on $LaAlO_3$ buffer layers grown on $SrTiO_3$ (100) substrates 314

Cathodic sputtering
mechanism of oxygenation of YBaCuO thin films during in situ growth by cathodic sputtering: effect of atomic oxygen 94
Chemical vapour deposition
precursors for chemical vapor deposition of yttrium barium copper oxide 254
Co-evaporation
properties of thin and ultra-thin YBCO films grown by a Co-evaporation technique 156
Critical current
field-anisotropy of critical current of YBaCuO films sputtered on various types of substrates 142
anisotropy of the critical current in YBCO thin films grown by metal organic chemical vapour deposition 351
Cuprate compounds
study of apical oxygen atoms in a spin-ladder cuprate compound by X-ray absorption spectroscopy near the Cu K edge 103

Defects
transmission electron microscopy investigations of defects in molecular beam epitaxy-grown oxide films 11
effects of columnar defects and intrinsic pinning on the Bose-glass transitions of $YBa_2Cu_3O_7$ and $Bi_2Sr_2CaCu_2O_8$ thin films 138
Defect structure
the relation between the defect structure, the surface roughness and the growth conditions of $YBa_2Cu_3O_{7-\delta}$ films 27
Deposition
YSZ buffer layers on technical substrates for HTSC current applications prepared by AAMOCVD 307
Deposition kinetics
single-source MOCVD of Y-, Ba- and Cu-oxides from thd-precursors 249
Deposition rate decrease
an improvement of surface smoothness and lattice match of CeO_2 buffer layers on R-sapphire processed by MOCVD 318
Deposition temperature
evidence of a "notch effect" in microwave surface resistance versus deposition temperature for $Y_1Ba_2Cu_3O_{7-x}$ thin film on MgO (100) substrate 166
Devices
MOCVD routes to Tl-2212/MgO/Tl-2212 trilayers — preliminary observations on growth and microstructural/electrical properties 328
Dielectrics
MOCVD routes to Tl-2212/MgO/Tl-2212 trilayers — preliminary observations on growth and microstructural/electrical properties 328
Doping
characteristic doping-dependent properties of HTS cuprate thin films prepared via MOCVD 347

Electrical properties
structural and electrical properties of $PrBa_2Cu_{3-x}Ga_xO_7$ ($x = 0.2$) thin films and $[PrBa_2Cu_{3-x}Ga_xO_7)_M/(YBa_2Cu_3O_7)_n]_P$ superlattices grown by pulsed laser deposition 209
characteristic doping-dependent properties of HTS cuprate thin films prepared via MOCVD 347

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Epitaxial films
superconducting properties of $Y_xHo_{1-x}Ba_2Cu_3O_7$ epitaxial films 303
Epitaxial layers
MOCVD of perovskites with metallic conductivity 337
Excitation
oxygen depth profiling using the $^{16}O(d,\alpha)^{14}N$ nuclear reaction 111

Fabrication
fabrication and properties of *c*-axis and *a*-axis oriented $EuBa_2Cu_3O_7/SrTiO_3$ superlattices 218
Film evolution
nucleation and growth of $YBa_2Cu_3O_{7-\delta}$ on wavy step edges in (001) $LaAlO_3$ 19
Film growth
X-ray diffraction analysis of YBaCuO ultra-thin film growth 65
FIR reflectance
optical phonons probe of the $SrLaAlO_4$ crystal structure 7
Flux creep
influence of the magnetic field sweep rate on flux creep in highly textured thin film of $YBa_2Cu_3O_{7-\delta}$ 150
Flux flow
micron scale stacked structures fabricated from BSCCO 2212 single crystal whiskers 236
FTIR
a study by FTIR and mass spectroscopy of the decomposition of precursors for the MOCVD of high temperature superconductors 297

Gas phase composition control
MOCVD with gas phase composition control for the growth of high quality $YBa_2Cu_3O_{7-x}$ thin films for microwave applications 292
Gas phase thermal decomposition
a study by FTIR and mass spectroscopy of the decomposition of precursors for the MOCVD of high temperature superconductors 297
Gibbs energy
Gibbs energy and growth habits of YBCO 56
Grain boundary structure
influence of the growth mechanism on the grain boundary structure in $YBa_2Cu_3O_7$ thin film bicrystals 78
Growth
effects of in-plane high angle grain boundaries in $YBa_2Cu_3O_7$ thin films epitaxially grown on (100) MgO on their physical properties 74
influence of the growth mechanism on the grain boundary structure in $YBa_2Cu_3O_7$ thin film bicrystals 78
Growth conditions
the relation between the defect structure, the surface roughness and the growth conditions of $YBa_2Cu_3O_{7-\delta}$ films 27
Growth defects
growth defects and interface roughness in $YBa_2Cu_3O_7/SrTiO_3$ superlattices grown by pulsed laser ablation 185

Halide CVD
TEM investigation of halide CVD grown $Bi_2Sr_2CaCu_2O_{8+x}$ films 134
Heteroepitaxy
growth of $YBa_2Cu_3O_7/CeO_2/Al_2O_3$ heteroepitaxial films by aerosol MOCVD 284

High-resolution tunnelling electron microscopy analysis
preparation of BiSrCaCuO thin films by atomic layer-by-layer molecular-beam-epitaxy and high-resolution transmission electron microscopy analysis of the film/substrate interface and of growth defects 44
High-Tc superconductors
field-anisotropy of critical current of YBaCuO films sputtered on various types of substrates 142
High temperature superconducting
HTS thin films by innovative MOCVD processes 264
High-temperature superconducting oxide thin films
twinning behaviour in YBCO and PBCO thin films and in PBCO–YBCO superlattices 322
High temperature superconductor devices
tunnelling barriers for high temperature superconductor devices 196
High temperature superconductors
abnormal Raman intensity enhancement of Cu–Cu vibration with film thickness reduction in $YBaCuO_{7-\delta}$ on $LaSrAlO_4$ 70
a study by FTIR and mass spectroscopy of the decomposition of precursors for the MOCVD of high temperature superconductors 297
High-T_c superconductors
persistent photoinduced superconductivity 87
electronic structure of the copper oxides ladder compounds $La_2Cu_2O_5$ and $SrCu_2O_3$ in a weak coupling model 222
High-T_c tunnel junctions
atomic-layer fabrication of high-T_c tunnel junctions 201
HREM
characterisation of multilayer ramp-type $REBa_2Cu_3O_{7-\delta}$ structures by scanning probe microscopy and high-resolution electron microscopy 206
HTSc
$srLaGaO_4$–$SrLaAlO_4$ solid solutions: new promising substrate materials for HTSc 1
HTS films
industrial metalorganic chemical vapor deposition technology for the growth of $YBa_2Cu_3O_{7-\delta}$ 360
HTS materials
preparation of buffer layers for HTS materials by MOCVD 310

Injection MOCVD
synthesis and characterisation of YBCO thin films grown by injection-MOCVD 288
Interface
characterization of the interface between laser ablated YBCO film and buffered sapphire substrate 41
abnormal Raman intensity enhancement of Cu–Cu vibration with film thickness reduction in $YBaCuO_{7-\delta}$ on $LaSrAlO_4$ 70
Interface roughness
growth defects and interface roughness in $YBa_2Cu_3O_7/SrTiO_3$ superlattices grown by pulsed laser ablation 185
Intrinsic Josephson effect
micron scale stacked structures fabricated from BSCCO 2212 single crystal whiskers 236
Isotropic electrical behaviour
twin-free $YBa_2Cu_3O_{7-\delta}$ films on (001) $NdGaO_3$ showing isotropic electrical behaviour 114

Ladder compounds
electronic structure of the copper oxides ladder compounds $La_2Cu_2O_5$ and $SrCu_2O_3$ in a weak coupling model 222

Large area deposition
large area deposition of YBCO-films by pulsed laser deposition for microwave applications 176
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Laser ablated YBCO thin films
the effect of selected process parameters on laser ablated YBCO thin films on $SrTiO_3$ substrates 123
Laser annealing
Raman spectroscopy as analytical tool for the local structure of $YBa_2Cu_3O_x$ thin films 99
Laser induced plasma
optical and photoacoustic studies of target ablation for LPVD of YBCO thin films 48
Lattice dynamics calculations
optical phonons probe of the $SrLaAlO_4$ crystal structure 7
Lattice parameters
stress and microstructure in YBaCuO thin films on MgO and $SrTiO_3$ substrates studied by X-ray diffraction and bending tests 37
LPVD
optical and photoacoustic studies of target ablation for LPVD of YBCO thin films 48

Magnetoresistance
MOCVD of HTS and GMR perovskites by aerosol and liquid delivery MOCVD 270
Magnetron sputtering
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Mass spectroscopy
a study by FTIR and mass spectroscopy of the decomposition of precursors for the MOCVD of high temperature superconductors 297
MBE
MBE Growth of compounds on the copper rich side of the (Sr,Ca)CuO system 240
Metallic conductivity
MOCVD of perovskites with metallic conductivity 337
Metal–organic chemical vapor deposition
twinning behaviour in YBCO and PBCO thin films and in PBCO–YBCO superlattices 322
MgO
effects of in-plane high angle grain boundaries in $YBa_2Cu_3O_7$ thin films epitaxially grown on (100) MgO on their physical properties 74
Microstructure
substrate-mediated control of the microstructure of $YBa_2Cu_3O_{7-\delta}$ thin films 23
stress and microstructure in YBaCuO thin films on MgO and $SrTiO_3$ substrates studied by X-ray diffraction and bending tests 37
Microwave application
characterization of the interface between laser ablated YBCO film and buffered sapphire substrate 41
Microwave applications
MOCVD with gas phase composition control for the growth of high quality $YBa_2Cu_3O_{7-x}$ thin films for microwave applications 292
Microwave properties
effects of in-plane high angle grain boundaries in $YBa_2Cu_3O_7$ thin films epitaxially grown on (100) MgO on their physical properties 74
Microwave surface resistance
evidence of a "notch effect" in microwave surface resistance versus deposition temperature for $Y_1Ba_2Cu_3O_{7-x}$ thin film on MgO (100) substrate 166
MOCVD
MOCVD precursor design issues. Recent advances in the chemistry and vapor pressure characteristics of Ba(hexafluoroacetylacetonate)$_2$ · polyether complexes 243
single-source MOCVD of Y-, Ba- and Cu-oxides from thd-precursors 249
precursors for chemical vapor deposition of yttrium barium copper oxide 254
HTS thin films by innovative MOCVD processes 264
MOCVD of HTS and GMR perovskites by aerosol and liquid delivery MOCVD 270
growth of $YBa_2Cu_3O_7/CeO_2/Al_2O_3$ heteroepitaxial films by aerosol MOCVD 284
MOCVD with gas phase composition control for the growth of high quality $YBa_2Cu_3O_{7-x}$ thin films for microwave applications 292
preparation of buffer layers for HTS materials by MOCVD 310
growth of epitaxial TlBaCaCuO *a*-axis oriented films on $LaAlO_3$ buffer layers grown on $SrTiO_3$ (100) substrates 314
an improvement of surface smoothness and lattice match of CeO_2 buffer layers on R-sapphire processed by MOCVD 318
MOCVD routes to Tl-2212/MgO/Tl-2212 trilayers — preliminary observations on growth and microstructural/electrical properties 328
MOCVD of perovskites with metallic conductivity 337
metalorganic chemical vapour deposition of high quality $LuBa_2Cu_3O_{7-\delta}$ thin films. Peculiarities of growth and superconducting properties 342
characteristic doping-dependent properties of HTS cuprate thin films prepared via MOCVD 347
industrial metalorganic chemical vapor deposition technology for the growth of $YBa_2Cu_3O_{7-\delta}$ 360
Modulated magnetron sputtering
glancing incidence X-ray characterization of ultrathin $YBa_2Cu_3O_{7-x}$ films fabricated by modulated magnetron sputtering 83
Modulated sputtering process
modulated sputtering process for smooth surface YBCO film deposition 34
Molecular beam epitaxy
transmission electron microscopy investigations of defects in molecular beam epitaxy-grown oxide films 11
preparation of BiSrCaCuO thin films by atomic layer-by-layer molecular-beam-epitaxy and high-resolution transmission electron microscopy analysis of the film/substrate interface and of growth defects 44
Multilayer
MOCVD routes to Tl-2212/MgO/Tl-2212 trilayers — preliminary observations on growth and microstructural/electrical properties 328
Multilayers
smooth and low outgrowth-density $Pr_1Ba_2Cu_3O_{7-x}/Y_1Ba_2Cu_3O_{7-x}$ pulsed laser deposited thin films for ramp junctions 213
twinning behaviour in YBCO and PBCO thin films and in PBCO–YBCO superlattices 322
Multistep KrF excimer laser deposition
Y–Ba–Cu–O thick film preparation using multistep KrF excimer laser deposition 228

Nuclear microanalysis
oxygen depth profiling using the $^{16}O(d,\alpha)^{14}N$ nuclear reaction 111
Nucleation
nucleation and growth of $YBa_2Cu_3O_{7-\delta}$ on wavy step edges in (001) $LaAlO_3$ 19

Outgrowths
smooth and low outgrowth-density $Pr_1Ba_2Cu_3O_{7-x}/Y_1Ba_2Cu_3O_{7-x}$ pulsed laser deposited thin films for ramp junctions 213
Oxide films
transmission electron microscopy investigations of defects in molecular beam epitaxy-grown oxide films 11
Oxygenation
mechanism of oxygenation of YBaCuO thin films during in situ growth by cathodic sputtering: effect of atomic oxygen 94

Perovskite films
MOCVD of perovskites with metallic conductivity 337
Phase separation
Raman spectroscopy as analytical tool for the local structure of $YBa_2Cu_3O_x$ thin films 99
Photoconductivity
persistent photoinduced superconductivity 87
PLD films
mapping the variations in properties of PLD films of YBCO deposited over large areas 172
Post deposition annealing
an improvement of surface smoothness and lattice match of CeO_2 buffer layers on R-sapphire processed by MOCVD 318
Precursor matrix
effect of Ba–Ca–Cu precursor matrix on the formation and properties of superconducting $Tl_2Ba_2Ca_{n-1}Cu_nO_x$ films. A combined metalorganic chemical vapour deposition and thallium vapour diffusion approach 332
Process parameters
the effect of selected process parameters on laser ablated YBCO thin films on $SrTiO_3$ substrates 123
Properties
fabrication and properties of *c*-axis and *a*-axis oriented $EuBa_2Cu_3O_7/SrTiO_3$ superlattices 218
Pulsed laser ablation
growth defects and interface roughness in $YBa_2Cu_3O_7/SrTiO_3$ superlattices grown by pulsed laser ablation 185
Pulsed laser deposition
characterization of the interface between laser ablated YBCO film and buffered sapphire substrate 41
large area deposition of YBCO-films by pulsed laser deposition for microwave applications 176
smooth and low outgrowth-density $Pr_1Ba_2Cu_3O_{7-x}/Y_1Ba_2Cu_3O_{7-x}$ pulsed laser deposited thin films for ramp junctions 213
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Pulsed organo–metallic beam-epitaxy
the growth of (001) $YBa_2Cu_3O_{(7-\delta)}$ thin films on (001) MgO by pulsed organo–metallic beam epitaxy with controlled in-plane orientation 278

Raman
abnormal Raman intensity enhancement of Cu–Cu vibration with film thickness reduction in $YBaCuO_{7-\delta}$ on $LaSrAlO_4$ 70
Raman scattering
optical phonons probe of the $SrLaAlO_4$ crystal structure 7
Raman spectroscopy as analytical tool for the local structure of $YBa_2Cu_3O_x$ thin films 99
Ramps
characterisation of multilayer ramp-type $REBa_2Cu_3O_{7-\delta}$ structures by scanning probe microscopy and high-resolution electron microscopy 206
Reactive sputtering
model for reactive sputtering. Optimisation result for YBaCuO thin films deposited on polycrystalline zirconia substrates 107
Resistive fault–current-limiter
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Roughness
smooth and low outgrowth-density $Pr_1Ba_2Cu_3O_{7-x}/Y_1Ba_2Cu_3O_{7-x}$ pulsed laser deposited thin films for ramp junctions 213

Sapphire substrates
$YBa_2Cu_3O_{7-\delta}/SrTiO_3$ epitaxial heterostructures on sapphire substrates 193
Secondary ion mass spectrometry
characterisation of thin film superconducting multilayers and their interfaces using secondary ion mass spectrometry 355
Spectroscopic ellipsometry
in-situ growth studies of sputtered YBCO thin films by spectroscopic ellipsometry 15
Spectroscopy
optical and photoacoustic studies of target ablation for LPVD of YBCO thin films 48
Spin-ladders
study of apical oxygen atoms in a spin-ladder cuprate compound by X-ray absorption spectroscopy near the Cu K edge 103
SPM
characterisation of multilayer ramp-type $REBa_2Cu_3O_{7-\delta}$ structures by scanning probe microscopy and high-resolution electron microscopy 206
Sputtered YBCO thin-films
in-situ growth studies of sputtered YBCO thin films by spectroscopic ellipsometry 15
$SrLaGaO_4$–$SrLaAlO_4$ solid solutions
$srLaGaO_4$–$SrLaAlO_4$ solid solutions: new promising substrate materials for HTSc 1
SrTiO3 substrates
the effect of selected process parameters on laser ablated YBCO thin films on $SrTiO_3$ substrates 123
Stacked structures
micron scale stacked structures fabricated from BSCCO 2212 singl crystal whiskers 236
Stress
stress and microstructure in YBaCuO thin films on MgO and $SrTiO_3$ substrates studied by X-ray diffraction and bending test 37
Structural properties
structural and electrical properties of $PrBa_2Cu_{3-x}Ga_xO_7$ ($x = 0.2$) thin films and $[PrBa_2Cu_{3-x}Ga_xO_7)_M/(YBa_2Cu_3O_7)_N]_P$ superlattices grown by pulsed laser deposition 209
Substrates
growth and electrochemical oxidation of MBE-grown *c*-axis La_2CuO_4 thin films on different substrates 118
Superconducting multilayers
characterisation of thin film superconducting multilayers and their interfaces using secondary ion mass spectrometry 355

Superconducting thick films
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Superconducting thin film
characterization of the interface between laser ablated YBCO film and buffered sapphire substrate 41
Superconducting thin films
effect of Ba–Ca–Cu precursor matrix on the formation and properties of superconducting $Tl_2Ba_2Ca_{n-1}Cu_nO_x$ films. A combined metalorganic chemical vapour deposition and thallium vapour diffusion approach 332
Superconduction
synthesis and characterisation of YBCO thin films grown by injection-MOCVD 288
superconducting properties of $Y_xHo_{1-x}Ba_2Cu_3O_7$ epitaxial films 303
Superconductivity
growth of $YBa_2Cu_3O_7/CeO_2/Al_2O_3$ heteroepitaxial films by aerosol MOCVD 284
Superconductivity in power engineering
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Superconductors
surface roughness and height–height correlations dependence on thickness of YBaCuO thin films 31
Superlattices
growth defects and interface roughness in $YBa_2Cu_3O_7/SrTiO_3$ superlattices grown by pulsed laser ablation 185
structural and electrical properties of $PrBa_2Cu_{3-x}Ga_xO_7$ ($x = 0.2$) thin films and $[PrBa_2Cu_{3-x}Ga_xO_7)_M/(YBa_2Cu_3O_7)_N]_P$ superlattices grown by pulsed laser deposition 209
fabrication and properties of *c*-axis and *a*-axis oriented $EuBa_2Cu_3O_7/SrTiO_3$ superlattices 218
Surface roughness
the relation between the defect structure, the surface roughness and the growth conditions of $YBa_2Cu_3O_{7-\delta}$ films 27
surface roughness and height–height correlations dependence on thickness of YBaCuO thin films 31

TEM
TEM investigation of halide CVD grown $Bi_2Sr_2CaCu_2O_{8+x}$ films 134
metalorganic chemical vapour deposition of high quality $LuBa_2Cu_3O_{7-\delta}$ thin films. Peculiarities of growth and superconducting properties 342
TGA
MOCVD precursor design issues. Recent advances in the chemistry and vapor pressure characteristics of Ba(hexafluoroacetylacetonate)$_2$ · polyether complexes 243
Thallium vapour diffusion
growth of epitaxial TlBaCaCuO *a*-axis oriented films on $LaAlO_3$ buffer layers grown on $SrTiO_3$ (100) substrates 314
effect of Ba–Ca–Cu precursor matrix on the formation and properties of superconducting $Tl_2Ba_2Ca_{n-1}Cu_nO_x$ films. A combined metalorganic chemical vapour deposition and thallium vapour diffusion approach 332
Thermal boundary resistance
interface thermal modelling and characterisation of YBaCuO infrared bolometers 232
Thermal co-evaporation
large area deposition of YBCO thick films for applications in resistive fault current limiting devices 366
Thermal modelling
interface thermal modelling and characterisation of YBaCuO infrared bolometers 232
Thermodynamic transitions
effects of columnar defects and intrinsic pinning on the Bose-glass transitions of $YBa_2Cu_3O_7$ and $Bi_2Sr_2CaCu_2O_8$ thin films 138
Thin film
nucleation and growth of $YBa_2Cu_3O_{7-\delta}$ on wavy step edges in (001) $LaAlO_3$ 19
persistent photoinduced superconductivity 87
influence of the magnetic field sweep rate on flux creep in highly textured thin film of $YBa_2Cu_3O_{7-\delta}$ 150
characterisation of thin film superconducting multilayers and their interfaces using secondary ion mass spectrometry 355
Thin films
preparation of BiSrCaCuO thin films by atomic layer-by-layer molecular-beam-epitaxy and high-resolution transmission electron microscopy analysis of the film/substrate interface and of growth defects 44
abnormal Raman intensity enhancement of Cu–Cu vibration with film thickness reduction in $YBaCuO_{7-\delta}$ on $LaSrAlO_4$ 70
effects of in-plane high angle grain boundaries in $YBa_2Cu_3O_7$ thin films epitaxially grown on (100) MgO on their physical properties 74
Raman spectroscopy as analytical tool for the local structure of $YBa_2Cu_3O_x$ thin films 99
study of apical oxygen atoms in a spin-ladder cuprate compound by X-ray absorption spectroscopy near the Cu K edge 103
growth and electrochemical oxidation of MBE-grown *c*-axis La_2CuO_4 thin films on different substrates 118
effects of columnar defects and intrinsic pinning on the Bose-glass transitions of $YBa_2Cu_3O_7$ and $Bi_2Sr_2CaCu_2O_8$ thin films 138
field-anisotropy of critical current of YBaCuO films sputtered on various types of substrates 142
AC susceptibility measurements of films with different structural qualities 179
structural and electrical properties of $PrBa_2Cu_{3-x}Ga_xO_7$ ($x = 0.2$) thin films and $[PrBa_2Cu_{3-x}Ga_xO_7)_M/(YBa_2Cu_3O_7)_N]_P$ superlattices grown by pulsed laser deposition 209
MBE Growth of compounds on the copper rich side of the (Sr,Ca)CuO system 240
single-source MOCVD of Y-, Ba- and Cu-oxides from thd-precursors 249
precursors for chemical vapor deposition of yttrium barium copper oxide 254
HTS thin films by innovative MOCVD processes 264
growth of $YBa_2Cu_3O_7/CeO_2/Al_2O_3$ heteroepitaxial films by aerosol MOCVD 284
MOCVD with gas phase composition control for the growth of high quality $YBa_2Cu_3O_{7-x}$ thin films for microwave applications 292
Tl-2212
MOCVD routes to Tl-2212/MgO/Tl-2212 trilayers — preliminary observations on growth and microstructural/electrical properties 328
characteristic doping-dependent properties of HTS cuprate thin films prepared via MOCVD 347
Transmission electron microscopy
transmission electron microscopy investigations of defects in molecular beam epitaxy-grown oxide films 11
nucleation and growth of $YBa_2Cu_3O_{7-\delta}$ on wavy step edges in (001) $LaAlO_3$ 19

Tunnelling barriers
tunnelling barriers for high temperature superconductor devices 196
Twinning
twinning behaviour in YBCO and PBCO thin films and in PBCO–YBCO superlattices 322

Ultrathin $YBa_2Cu_3O_{7-x}$ films
glancing incidence X-ray characterization of ultrathin $YBa_2Cu_3O_{7-x}$ films fabricated by modulated magnetron sputtering 83

Weak coupling
electronic structure of the copper oxides ladder compounds $La_2Cu_2O_5$ and $SrCu_2O_3$ in a weak coupling model 222

X-Ray absorption spectroscopy
study of apical oxygen atoms in a spin-ladder cuprate compound by X-ray absorption spectroscopy near the Cu K edge 103
XRD
metalorganic chemical vapour deposition of high quality $LuBa_2Cu_3O_{7-\delta}$ thin films. Peculiarities of growth and superconducting properties 342

YBaCuO
nucleation and growth of $YBa_2Cu_3O_{7-\delta}$ on wavy step edges in (001) $LaAlO_3$ 19
effects of in-plane high angle grain boundaries in $YBa_2Cu_3O_7$ thin films epitaxially grown on (100) MgO on their physical properties 74
$YBa_2Cu_3O_{7-\delta}$ films
the relation between the defect structure, the surface roughness and the growth conditions of $YBa_2Cu_3O_{7-\delta}$ films 27
twin-free $YBa_2Cu_3O_{7-\delta}$ films on (001) $NdGaO_3$ showing isotropic electrical behaviour 114
$YBa_2Cu_3O_{7-x}$/metal point contact interface
the influence of bias voltage on $YBa_2Cu_3O_{7-x}$/metal point contact interface 129
$YBa_2Cu_3O_{7-\delta}/SrTiO_3$
$YBa_2Cu_3O_{7-\delta}/SrTiO_3$ epitaxial heterostructures on sapphire substrates 193
Y–Ba–Cu–O thick film
Y–Ba–Cu–O thick film preparation using multistep KrF excimer laser deposition 228
$YBa_2Cu_3O_7$ thin film bicrystals
influence of the growth mechanism on the grain boundary structure in $YBa_2Cu_3O_7$ thin film bicrystals 78

YBaCuO thin films
substrate-mediated control of the microstructure of $YBa_2Cu_3O_{7-\delta}$ thin films 23
surface roughness and height–height correlations dependence on thickness of YBaCuO thin films 31
stress and microstructure in YBaCuO thin films on MgO and $SrTiO_3$ substrates studied by X-ray diffraction and bending test 37
X-ray diffraction analysis of YBaCuO ultra-thin film growth 65
mechanism of oxygenation of YBaCuO thin films during in situ growth by cathodic sputtering: effect of atomic oxygen 94
model for reactive sputtering. Optimisation result for YBaCuO thin films deposited on polycrystalline zirconia substrates 107
Y–Ba–Cu–O thin films
investigation of the magnetic flux density distribution, current distribution and magnetization curve of Y–Ba–Cu–O thin films 146
YBCO
optical and photoacoustic studies of target ablation for LPVD of YBCO thin films 48
Gibbs energy and growth habits of YBCO 56
mapping the variations in properties of PLD films of YBCO deposited over large areas 172
interface thermal modelling and characterisation of YBaCuO infrared bolometers 232
precursors for chemical vapor deposition of yttrium barium copper oxide 254
the growth of (001) $YBa_2Cu_3O_{(7-\delta)}$ thin films on (001) MgO by pulsed organo–metallic beam epitaxy with controlled in-plane orientation 278
YSZ buffer layers on technical substrates for HTSC current applications prepared by AAMOCVD 307
YBCO film deposition
modulated sputtering process for smooth surface YBCO film deposition 34
YBCO films
properties of thin and ultra-thin YBCO films grown by a Co-evaporation technique 156
anisotropic in-plane properties of 10° and (103)/(013) YBCO films 161
large area deposition of YBCO-films by pulsed laser deposition for microwave applications 176
YBCO thin films
anisotropy of the critical current in YBCO thin films grown by metal organic chemical vapour deposition 351